

Title (en)
Protective Ti-Al-Cr-N coating

Title (de)
Ti-Al-Cr-N Schutzschicht

Title (fr)
Couche protectrice de Ti-Al-Cr-N

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Application
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Abstract (en)
This invention relates to coatings for the protection of substrates operating at moderately elevated temperatures, and, more particularly, for the protection of titanium-alloy aircraft and stationary gas turbine components as well as engine components for automotive applications, articles having such coatings and a method for their production.

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